


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Pascal Huyghe et al.
Date Filed: June 27, 2003
Title: ***Method and System for Electronic Order Entry and
Automatic Processing of Photomask Orders***

This application claims the benefit of U.S. Provisional
Application Serial No. 60/392,567 filed June 28, 2002

Honorable Assistant Commissioner
for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this
Information Disclosure Statement
is being deposited with the United
States Postal Service as Express
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Patents, P.O. Box 1450,
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the date shown below.



Shannon Judice

6/27/03

Date

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

Applicants respectfully request, pursuant to 37 C.F.R. §§1.56, 1.97 and 1.98, that the references listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified application. Copies of the references are enclosed for the convenience of the Examiner. Furthermore, pursuant to 37 C.F.R. §§1.97 (g) and (h), no representation is made that these references are material to the patentability of the present application.

Applicants believe no fee is due, however, the Commissioner is hereby authorized to charge any additional fees or credit any overpayments to Deposit Account No. 50-2148 of Baker Botts L.L.P.

Respectfully submitted,

BAKER BOTTS L.L.P.
Attorneys for Applicants



Patrick J. Porter
Registration No. 45,658

Date: June 27, 2003

Correspondence Address:

Customer Number 31625

512.322.2690
512.322.8385 (Fax)



31625

PATENT TRADEMARK OFFICE

PTO-1449 Information Disclosure Citation in an Application		Application No. Unassigned Docket Number 064441.0263		Applicant(s) Pascal Huyghe et al. Group Art Unit Unknown Filing Date June 27, 2003			
U.S. PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	A.						
	B.						
	C.						
	D.						
	E.						
	F.						
	G.						
	H.						
	I.						
	J.						
	K.						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	L.						
	M.						
	N.						
	O.						
	P.						
	Q.						
NON-PATENT DOCUMENTS							
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE
	R.	Edward Suttile et al.'s "Streamlining the front-end reticle fabrication process by improving mask ordering" at internet address < http://www.micromagazine.com/archive/02/06/suttile.html > and published in June 2002 Issue of Micro Magazine. 10 Pages					June 2002
	S.	Brock Hotaling, "MaskPilot Revolutionizes Semiconductor Software," <u>Reticle and Mask Solutions</u> , Vol. I, No. 1, Fall 2002, 4 Pages					Fall 2002
	T.	Photonics, Inc., "Photonics eBeam Phase Masks: Tackling the Challenges of Special Lightwave Applications," <u>Reticle and Mask Solutions</u> , Vol. XIII, No. 1, Spring 2002, 4 Pages					Spring 2002
EXAMINER					DATE CONSIDERED		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							